

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITING PROCEDURE  
EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Van Beek, <i>et al.</i>	Docket No.:	EPC-019
Serial No.:	10/578,026	Art Unit:	2829
Filed:	March 13, 2007	Examiner:	Karen M. Kusumakar
		Conf. No.:	4725
For:	Method of Manufacturing a MEMS Device and MEMS Device		

W/RCE  
6/19/09  
JM

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 CFR § 1.116**

Dear Sir:

Applicant respectfully submits the following amendments and remarks in response to Examiner's Office Action dated March 5, 2009, which Action is made final. Applicant respectfully requests that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of the claims.